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Docket No.: 601882413

Corres. and Mail  
**BOX AF**

AF/2823

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

|                        |   |                                    |
|------------------------|---|------------------------------------|
| In re Application of   | : | <b>RESPONSE UNDER 37 CFR 1.116</b> |
|                        | : | <b><u>EXPEDITED PROCEDURE</u></b>  |
| Gaku SUGAHARA, et al.  | : |                                    |
|                        | : | Customer Number: 20277             |
| Serial No.: 09/890,095 | : |                                    |
|                        | : | Confirmation Number: 6059          |
|                        | : |                                    |
|                        | : | Group Art Unit: 2828               |
| Filed: July 27, 2001   | : |                                    |
|                        | : | Examiner: Dung T. Nguyen           |

For: SEMICONDUCTOR LASER DEVICE, METHOD FOR FABRICATING THE  
SAME, AND OPTICAL DISK APPARATUS

**REQUEST FOR RECONSIDERATION**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action dated February 24, 2004, having a shortened statutory period for response set to expire May 24, 2004, reconsideration of the above-identified application is respectfully requested in view of the following remarks.